



PATENT 5298-05700/PM01016

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Collier et al.

Serial No. 09/899,871

Filed: July 6, 2001

For: METHOD AND SYSTEM FOR

CLEANING A POLISHING PAD

Group Art Unit: 3723 Examiner: Wilson, L.

Atty. Dkt. No. 5298-05700

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22223, on paradate indicated below:

July 3, 2003

Date Kevin L. Daffe

RESPONSE AFTER FINAL REJECTION PURSUANT TO 37 CFR § 1.116

MS: AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

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Dear Sir/ Madam:

ECHNOLOGY CENTER R3700

This paper is submitted in response to the Office Action dated May 7, 2003 to further highlight reasons why the application is in condition for allowance.

Remarks/Arguments begin on page 2 of this paper.